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Application/Control No.	o. Applicant(s)/Patent under Reexamination	
10/629,688	LIN, JACK	
Examiner	Art Unit	
Jacob Y. Choi	2875	

SEARCHED						
CENTOTIED						
Class	Subclass	Date	Examiner			
362	345, 328, 307, 342	4/1/2005	JC			
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Class/Subclass Search 362 - Steven Husar	4/1/2005	JC	